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** CONTINUING DATA *****

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** FOREIGN APPLICATIONS *****

JAPAN 2004-112179 04/06/2004

** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **

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Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No					
Verified and Acknowledged	/SHARIDAN CARRILLO/ Examiner's Signature	Initials	JAPAN	7	30	3

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TITLE

Substrate cleaning apparatus, substrate cleaning method, and medium for recording program used for the method

FILING FEE RECEIVED 1960	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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